



PATENT  
3885-0103P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Yoshinobu ONO et al. Conf.: 2546  
Appl. No.: 10/046,741 Group: 2812  
Filed: January 17, 2002 Examiner: S. Mulpuri  
For: METHOD FOR FABRICATING III-V COMPOUND  
SEMICONDUCTOR

**AMENDMENT UNDER 37 C.F.R. 1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 9, 2004

Sir:

In reply to the Office Action dated September 9, 2003, the period for response having been extended by one (1) month until January 9, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes amendments to the specification, amended claim set and remarks.

01/13/2004 RNEBRANT 00000135 10046741

01 FC:1251

110.00 0P

RECEIVED  
JAN 15 2004  
TECHNOLOGY CENTER 2800